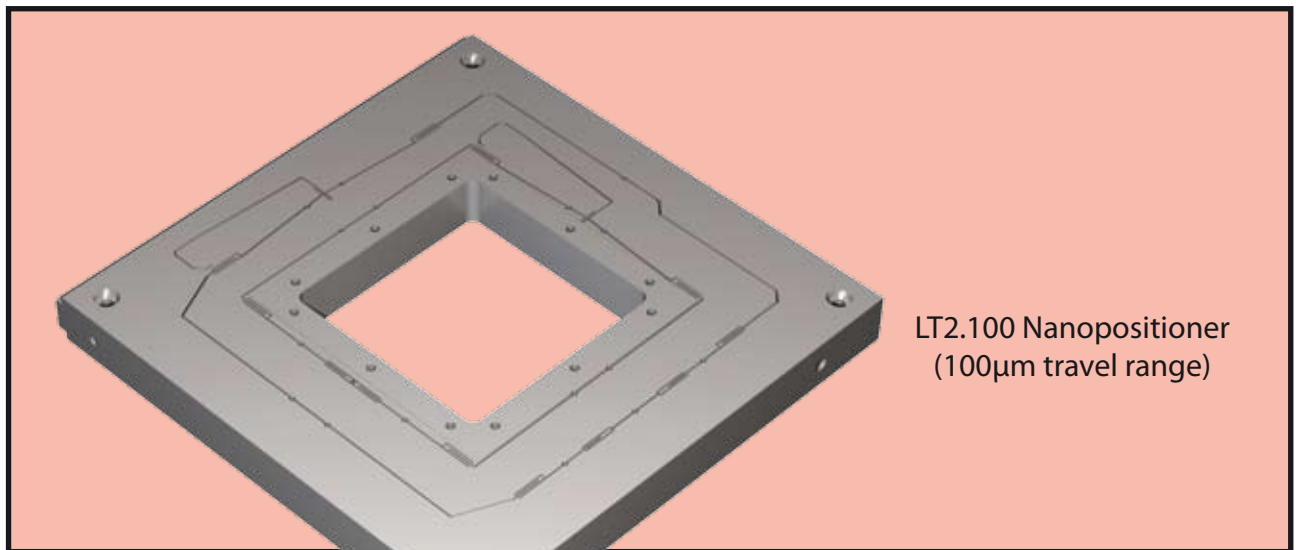


LT2 NANOPositionER

The LT2 is a 2-axis ultra-low profile nanopositioner designed to be integrated in any kind of inverted microscopes. This piezostage can be proposed with a coarse positioning Microstage (See our Hybrid System - pages 34-35).

As standard, the LT2 is made in Aluminium but for Bruker AFM upgrade, we can propose the LT2.100 (100 μ m version) in Invar, which leads to higher thermal stability.



Features

- Low profile
- Square aperture (66mm x 66mm)
- 100, 200 or 300 μ m motion
- Closed loop control
- Silicon sensor technology
- Less than 30pm noise floor

Applications

- Super Resolution microscopy
- Nanolithography
- Particle tracking
- Confocal microscopy
- Atomic Force Microscopy
- Bruker AFM upgrade

Specifications

	LT2.100	LT2.200	LT2.300
Range of motion XY (μm)	100	200	300
Resolution XY (nm)	0,1	0,2	0,3
Typical noise floor XY (nm)	0,01	0,02	0,03
Full range repeatability XY (nm)	0,2	0,4	0,6
Linearization (typical)	0,02%	0,02%	0,02%
Resonant frequency X/Y (Hz)	500/400	400/350	300/250
Stiffness (N/ μm)	0,6/0,5	0,5/0,4	0,4/0,3
Maximum load (kg) - horizontal use	1	1	1
Maximum load (kg) - vertical use	0,5	0,5	0,5
Sensor	Silicon HR sensor	Silicon HR sensor	Silicon HR sensor
Size W x L x H (mm)	155,5 x 152,5 x 15,5	155,5 x 152,5 x 15,5	155,5 x 152,5 x 15,5
Material	Al or Invar	Al	Al
Cable length (m)	2	2	2
Recommended Controller	Standard	Standard	Standard

Drawing

